



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEREOLITHOGRAPHIC
METHODS FOR FORMING A
PROTECTIVE LAYER ON A
SEMICONDUCTOR DEVICE SUBSTRATE
AND SUBSTRATES INCLUDING
PROTECTIVE LAYERS SO FORMED

Confirmation No.: 1415

Examiner: G. Lee

Group Art Unit: 2825

Attorney Docket No.: 2269-3923US
(99-0033.00/US)

Notice of Allowance Mailed:

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AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Serial No. 09/589,841

Amendments to the Specification begin on page 3 of this paper.

A Listing of the Claims begins on page 8 of this paper.

Remarks begin on page 17 of this paper.